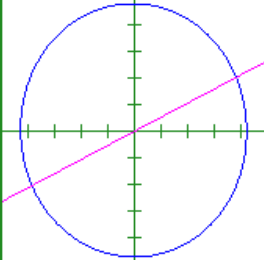
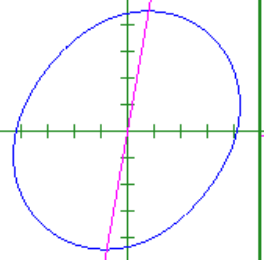
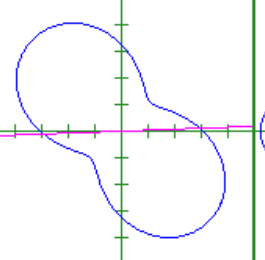
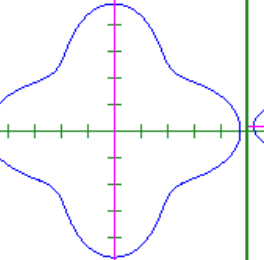
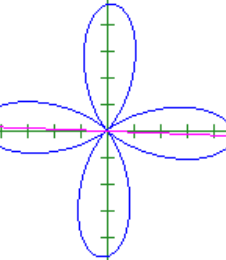


面内位相差測定

No.1	No.2	No.3	No.4	No.5
				
TAC_A	TAC_B	TAC_C	PC_A	PC_B
λ (nm) = 587.5 配向角 = -62.071 Re (nm) = 1.21 次数 = 1 d (μ m) = 8.00 Δn = 0.000151 Re' (nm) = 1.21 a/b = 0.9443 Ψ = 2.200	λ (nm) = 587.5 配向角 = -9.952 Re (nm) = 10.84 次数 = 1 d (μ m) = 82.00 Δn = 0.000132 Re' (nm) = 10.84 a/b = 0.8908 Ψ = 142.140	λ (nm) = 587.5 配向角 = -87.896 Re (nm) = 50.42 次数 = 1 d (μ m) = 40.00 Δn = 0.001261 Re' (nm) = 50.42 a/b = 0.5696 Ψ = 43.311	λ (nm) = 587.5 配向角 = 0.101 Re (nm) = 116.22 次数 = 1 d (μ m) = 64.00 Δn = 0.001816 Ratio = 0.99937 Re' (nm) = 116.22	λ (nm) = 587.5 配向角 = 87.824 Re (nm) = 281.40 次数 = 1 d (μ m) = 125.00 Δn = 0.002251 Ratio = 0.99868 Re' (nm) = 281.40

赤字No:低位相差測定(楕円偏光入射-検光子回転測定)

青地No:標準測定(平行ニコル回転法)

λ :測定波長

配向角:遅相軸方位(次数自動決定の時)

Re:レターデーション

次数:光学次数m

d:サンプル厚み(入力値)

Re':補正值(ユーザー任意)

Δn :複屈折値